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Sheet 1 of 1

FORM PTO-1449	U.S. DEPARTMENT OF COM

U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE

ATTY. DOCKET NO. 5000-4985 SERIAL NO. 10/053,212

APPLICANT

INFORMATION DISCLOSURE CITATION

Toshihisa SHIMO et al.

(Use several sheets if necessary) FILING DATE

FILING DATE

January 15, 2002

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U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
KIM-1.	4,889,885	12/26/89	Usuki et al.	524	445	3/4/88

FOREIGN PATENT DOCUMENTS

						CLASS	SUBCLASS	TRANSLATION	
}- -			DOCUMENT NUMBER	DATE	COUNTRY	C.2.103	SUBCLASS	YES	NO
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		4.	DE 36 21 686 A1	1/14/88	Germany	C09K	3/14		X
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KIM	7.		Choi, et al., XP-002236119, Chemistry of Materials, 12(10): 2977-2983 (2000).
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EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

M&F REV. 06/29/95

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Examiner

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